This Page Is Inserted by IFW Operations and is not a part of the Official Record

BEST AVAILABLE IMAGES

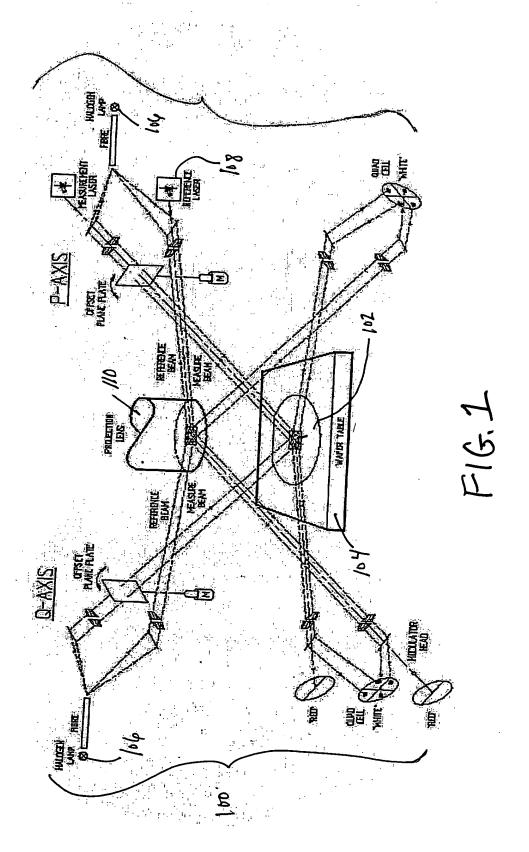
Defective images within this document are accurate representations of the original documents submitted by the applicant.

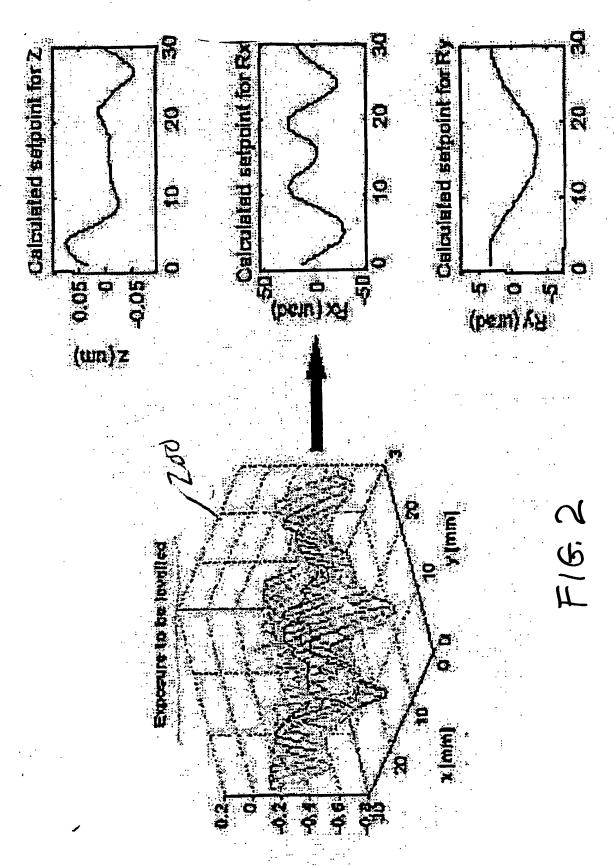
Defects in the images may include (but are not limited to):

- BLACK BORDERS
- TEXT CUT OFF AT TOP, BOTTOM OR SIDES
- FADED TEXT
- ILLEGIBLE TEXT
- SKEWED/SLANTED IMAGES
- COLORED PHOTOS
- BLACK OR VERY BLACK AND WHITE DARK PHOTOS
- GRAY SCALE DOCUMENTS

IMAGES ARE BEST AVAILABLE COPY.

As rescanning documents will not correct images, please do not report the images to the Image Problem Mailbox.



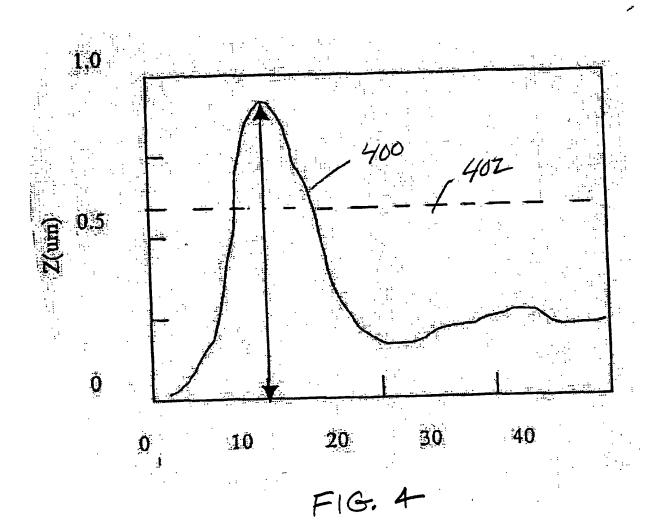


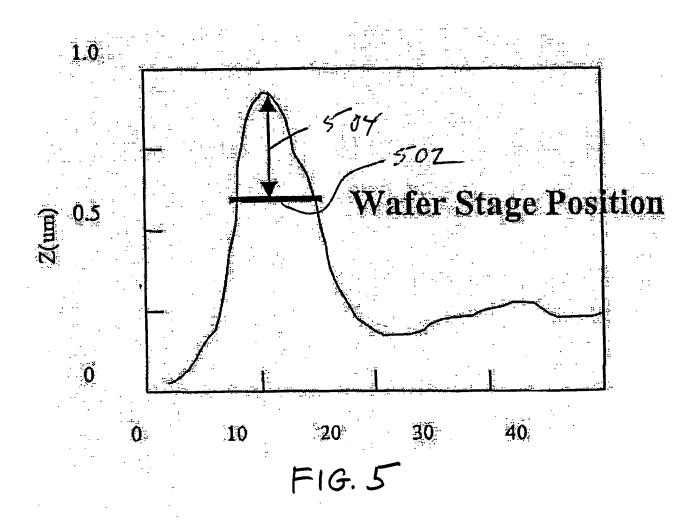
Docket No. N1085-00243 Inventors: Chun-Hung Lin et al. "A Method To Predict And Identify Defocus Wafers Sheet 3 of 7

FOCUS SPOT STATISTICS

			<u> </u>	<u> </u>	
٠,	Wafer	 Chuck		Deviations	*******************************
		ID	X [na]	Y	deviation
		 		 	[un]
4	1	1. 1.	-141.32400	7.80000	8.542148
		1	-126.69168	-66.64968	1.295974
. 1			-126.69168 -112.05928	51.04960 -66.64960	0.558704 1.586365
			-68.16200	-96.87448	1.500305 0.456564
	inin 1	1	-68.16200	109.89926	0.895035
.	1. 1 :		-53.52968 -53.52968	125.49928	1.113183
. [1	-9.63246	109.89920 139.32400	0.443870
į	1	i i.	5.00000	-125.49928	1.681745
1		1	63.52966	109.89928	6.573938
.			78.16206 92.79446	109.89926	1.017531
i	1	1	107.42688	80.47440	0.922599 1.547343
1	1	1	122.05926	-66.64960	0.665561
1	1		136.69168	-37.22480	0.404567
i	1		136.69166	-7.80000 21.62480	0.405736 0.503105
į	.2	2	-141.32406	-7.89600	0.543358
ļ	2	2	-125,69160	-66.64968	1.231986
I	2	2 2	-126.69160 -112.05920	51.04960 -66.64960	0.542519
j	2	2	-82.79446	109.89928	1.486671 8.778743
1	2	2	-68.16296	-125.49928	0.523200
1	2	2 2	-68.16208 -68.16208	-96.87448	8.488616
1	2	2	-53.52960	109.89920 -125.49920	8.812353 1.139583
•					1.137263

FIG. 3





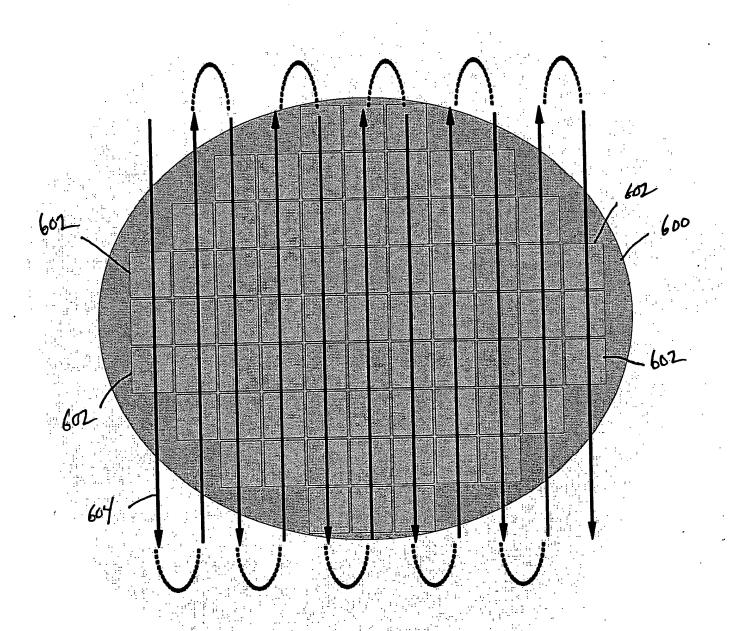


FIG. 6

